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APPLICANTS Masahiro Nakayama, Hyogo, JAPAN; Masato Irikura, Hyogo, JAPAN;				
** CONTINUING DATA *****				
** FOREIGN APPLICATIONS ***** JAPAN 98979/2003 04/02/2003 JAPAN 275935/2003 07/17/2003 YES DVN				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/08/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> <i>DVN</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS Stephen A. Becker McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington, DC20005-3096				
TITLE Chamfered freestanding nitride semiconductor wafer and method of chamfering nitride semiconductor wafer				
FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	